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TC 1700

PATENT APPLICATION

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Attorney Docket No.: 2950.01US02

Kambe et al.

Confirmation No.: 6755

Application No.: 09/841,255

Examiner: C. M. Koslow

Filed: April 24, 2001

Group Art Unit: 1755

For: ABRASIVE PARTICLES FOR SURFACE POLISHING

PRELIMINARY AMENDMENT

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to considering the enclosed RCE, and in accordance with the automatic extension of time for response provided by 37 C.F.R. § 1.136(a), amendment to the above-identified patent application is requested.

In the Claims

Please substitute the following amended claims for those currently pending:

1. (Twice Amended) A polishing composition comprising a dispersion of particles, the particles comprising a non-silicon metal compound and having an average particle diameter from about 5 nm to about 50 nm and a distribution of diameters such that at least about 95 percent of the particles have a diameter greater than about 60 percent of the average diameter and less than about 140 percent of the average diameter.

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